



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Large application of

: **Confirmation No. 6334**

Koji MISHIMA et al.

: Attorney Docket No. 2003_1305

Serial No. 10/660,483

: Group Art Unit 1742

Filed September 12, 2003

: Examiner William T. Leader

METHOD AND APPARATUS FOR PLATING
SUBSTRATE WITH COPPER

: **Mail Stop: RCE**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

A first month extension having been previously obtained, Petition is hereby made for a second and third month extension of time to respond to the communication of July 12, 2005.

The fee of \$900.00 is

(X) submitted herewith.

() to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.

() Small entity status of this application is established by a Small Entity Status Assertion which

() is enclosed.

() has been previously submitted.

Respectfully submitted,

Koji MISHIMA et al.

By

W. Douglas Hahm

Registration No.44,142

Attorney for Applicants

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900.00 DP

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December 29, 2005